Amendment dated: June 7, 2005

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AMENDMENTS TO THE CLAIMS

(Currently Amended) A slider, comprising: 1.

a magnetic head coupled to the slider, the magnetic head having a first set of electrical

pads to read data from a magnetic storage medium and a second set of electrical pads to write

data to the magnetic storage medium;

a charging electrical pad coupled to the slider separate from the magnetic head during a

wafer fabrication process; and

a charging electrical conductor coupled to the electrical pad to apply an electrical charge

to the slider.

2. (Original) The slider of claim 1, wherein the charging electrical pad is coupled to a

trailing edge of the slider.

3. (Cancelled)

4. (Original) The slider of claim 1, wherein the slider is coupled to a suspension.

5. (Original) The slider of claim 4, wherein the slider is electrically isolated from the

suspension.

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6. (Original) The slider of claim 5, wherein the slider is coupled to the suspension using an

adhesive with a high electrical resistance.

7. (Original) The slider of claim 1, wherein the slider is connected to an electronic feedback

system, the electronic feedback system to monitor an environmental condition of the slider.

8. (Original) The slider of claim 7, wherein the charging electrical conductor is connected

to the electronic feedback system, the charging electrical conductor applying the electrical charge

based upon a flying height of the slider.

9. (Original) The slider of claim 7, wherein the charging electrical conductor is connected

to the electronic feedback system, the charging electrical conductor applying the electrical charge

based upon a surrounding temperature of the slider.

10. (Original) The slider of claim 1, wherein the electrical charge ranges between 0.1 -5

volts.

11. (Currently Amended) A system, comprising:

a magnetic storage medium;

a suspension;

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a slider coupled to the suspension;

a magnetic head coupled to the slider, the magnetic head having a first set of electrical

pads to read data from the magnetic storage medium and a second set of electrical pads to write

data to the magnetic storage medium;

a charging electrical pad coupled to the slider separate from the magnetic head during a

wafer fabrication process; and

a charging electrical conductor coupled to the electrical pad to apply an electrical charge

to the slider.

12. (Original) The system of claim 11, wherein the charging electrical pad is coupled to a

trailing edge of the slider.

13. (Cancelled)

14. (Original) The system of claim 11, wherein the slider is electrically isolated from the

suspension.

15. (Original) The system of claim 11, wherein the slider is coupled to the suspension using

an adhesive with a high electrical resistance.

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16. (Original) The system of claim 11, wherein the slider is connected to an electronic feedback system, the electronic feedback system to monitor an environmental condition of the slider.

- 17. (Original) The system of claim 16, wherein the charging electrical conductor is connected to the electronic feedback system, the charging electrical conductor applying the electrical charge based upon a flying height of the slider.
- 18. (Original) The system of claim 16, wherein the charging electrical conductor is connected to the electronic feedback system, the charging electrical conductor applying the electrical charge based upon a surrounding temperature of the slider.
- 19. (Original) The system of claim 11, wherein the electrical charge ranges between 0.1 –5 volts.
- 20. (Currently Amended) A method, comprising:

suspending a slider above a magnetic data storage medium, the slider coupled to a charging electrical pad isolated electrically from a set of read electrical pads and a set of write electrical pads on the slider during a wafer fabrication process;

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applying an electrical voltage to the charging electrical pad to create an electrical charge on the slider in relation to the magnetic data storage medium.

21. (Original) The method of claim 20, wherein the charging electrical pad is coupled to a trailing edge of the slider.

- 22. (Cancelled)
- 23. (Original) The method of claim 20, wherein the slider is coupled to a suspension.
- 24. (Original) The method of claim 23, wherein the slider is electrically isolated from the suspension.
- (Original) The method of claim 23, wherein the slider is coupled to the suspension using 25. an adhesive with a high electrical resistance.
- 26. (Original) The method of claim 20, further including monitoring environmental conditions of the slider.

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- 27. (Original) The method of claim 26, further including applying the electrical charge based upon a flying height of the slider.
- 28. (Original) The method of claim 26, further including applying the electrical charge based upon a surrounding temperature of the slider.
- 29. (Original) The method of claim 20, wherein the electrical charge ranges between 0.1 –5 volts.